

Under the Paperwork Reduction Act of 1995, no persons are required to respond to a collection of information unless it contains a valid OMB control number.

Substitute for form 1449/PTO

**INFORMATION DISCLOSURE
STATEMENT BY APPLICANT**

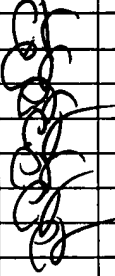
(Use as many sheets as necessary)

Complete if Known

Application Number	to be assigned
Filing Date	January 29, 2004
First Named Inventor	M. Nakasuji
Art Unit	to be assigned
Examiner Name	to be assigned
Attorney Docket Number	011470A

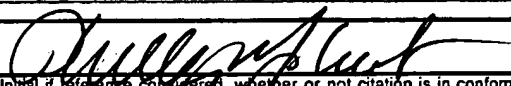
Sheet 1 of 2

U. S. PATENT DOCUMENTS

Examiner Initials*	Cite No. ¹	Document Number	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number-Kind Code ² (if known)			
		US- 6,125,522	10/3/00	Nakasuji	
		US- 6,087,667	7/11/00	Nakasuji, et al.	
		US- 5,981,947	11/9/99	Nakasuji, et al.	
		US- 5,892,224	4/6/99	Nakasuji	
		US- 5,359,197	10/25/94	Komatsu, et al.	
		US- 4,912,052	3/27/90	Miyoshi, et al.	
		US- 4,726,689	2/23/88	Pollock	
		US-			
		US-			
		US-			
		US-			
		US-			
		US-			
		US-			
		US-			
		US-			
		US-			
		US-			
		US-			
		US-			

FOREIGN PATENT DOCUMENTS

Examiner Initials*	Cite No. ¹	Foreign Patent Document	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages Or Relevant Figures Appear	T ⁶
		Country Code ³ Number ⁴ Kind Code ⁵ (if known)				

Examiner
SignatureDate
Considered

10-8-04

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant. ¹ Applicant's unique citation designation number (optional). ² See Kinds Codes of USPTO Patent Documents at www.uspto.gov or MPEP 901.04. ³ Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). ⁴ For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. ⁵ Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST.16 if possible. ⁶ Applicant is to place a check mark here if English language translation is attached.

This collection of information is required by 37 CFR 1.97 and 1.98. The information is required to obtain or retain a benefit by the public which is to file (and by the USPTO to process) an application. Confidentiality is governed by 35 U.S.C. 122 and 37 CFR 1.14. This collection is estimated to take 2 hours to complete, including gathering, preparing, and submitting the completed application form to the USPTO. Time will vary depending upon the individual case. Any comments on the amount of time you require to complete this form and/or suggestions for reducing this burden, should be sent to the Chief Information Officer, U.S. Patent and Trademark Office, P.O. Box 1450, Alexandria, VA 22313-1450. DO NOT SEND FEES OR COMPLETED FORMS TO THIS ADDRESS. SEND TO: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

If you need assistance in completing the form, call 1-800-PTO-9199 (1-800-786-9199) and select option 2.

Under the Paperwork Reduction Act of 1995, no persons are required to respond to a collection of information unless it contains a valid OMB control number.

Substitute for form 1449/PTO INFORMATION DISCLOSURE STATEMENT BY APPLICANT (Use as many sheets as necessary)		Complete if Known			
		Applicati n Number	to be assigned		
		Filing Date	January 29, 2004		
		First Named Inventor	M. Nakasuji		
		Art Unit	to be assigned		
		Examiner Name	to be assigned		
Sheet	2	of	2	Attorney Docket Number	011470A

NON PATENT LITERATURE DOCUMENTS			
Examiner Initials*	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²
cy	1	Sandland; "An Electron-beam inspection system for x-ray mask production", J. of Vacuum Sci & Tech.B (1991) Vol. 9, No. 6; pp3005-3009	
cy	2	Meisburger et al; "Requirements and performance of an electron-beam column designed for x-ray mask inspection"; J. of Vacuum Sci & Tech.B (1991) Vol. 9, No. 6; pp 3010-3014	
cy	3	Lischke et al; "Multi-beam concepts for Nanometer Devices"; JP J. Applied Physics (1989) Vol. 28, pp 2058-64.	
cy	4	Electron/Ion Beam Handbook 2nd; Nikkan Kogyo (1988) pp 115-119 (with partial English Translation).	
cy	5	U.S. Patent Application S.N. 09/985,323; filed 11/2/2001; Mamoru Nakasuji et al; "Electron Beam Apparatus and Device Production Method Using the Electron Beam Apparatus"	
cy	6	U.S. Patent Application S.N. 09/985,324; filed 11/2/2001; Toshifumi Kimba et al; "Apparatus for Inspecting Material with Electron Beam, Method for Operating Same, and ...	
cy	7	U.S. Patent Application S.N. 09/985,325; filed 11/2/2001; Mamoru Nakasuji et al; "Electron Beam Apparatus and Method of Manufacturing Semiconductor Device Using the ..."	
cy	8	U.S. Patent Application S.N. 09/985,331; filed 11/2/2001; Mamoru Nakasuji et al; "Method for Inspecting Substrate, Substrate Inspecting System and Electron Beam Apparatus"	

Examiner Signature		Date Considered	10-8-04
--------------------	---	-----------------	---------

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

1 Applicant's unique citation designation number (optional). 2 Applicant is to place a check mark here if English language Translation is attached. This collection of information is required by 37 CFR 1.98. The information is required to obtain or retain a benefit by the public which is to file (and by the USPTO to process) an application. Confidentiality is governed by 35 U.S.C. 122 and 37 CFR 1.14. This collection is estimated to take 2 hours to complete, including gathering, preparing, and submitting the completed application form to the USPTO. Time will vary depending upon the individual case. Any comments on the amount of time you require to complete this form and/or suggestions for reducing this burden, should be sent to the Chief Information Officer, U.S. Patent and Trademark Office, P.O. Box 1450, Alexandria, VA 22313-1450. DO NOT SEND FEES OR COMPLETED FORMS TO THIS ADDRESS. SEND TO: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

If you need assistance in completing the form, call 1-800-PTO-9199 (1-800-786-9199) and select option 2.